

10/552262

JC20 Rec'd PCT/PTO 05 OCT 2005  
PATENT

Attorney Docket :  
33082 M 275

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kazuhide HASEBE, et al.

International Application No.: PCT/JP2004/005643

International Filing Date: April 20, 2004

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: SILICON DIOXIDE FILM REMOVING METHOD AND PROCESSING SYSTEM

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the International Search Report (ISR) being filed herewith. According to the ISR, document AA on the enclosed PTO-1449 is a counterpart of document AM, and document AB is a counterpart of document AO. Copies of all cited foreign documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,  
SMITH, GAMBRELL & RUSSELL, LLP

By:

  
Michael A. Makuch, Reg. No. 32,263  
1850 M Street, N.W., Suite 800  
Washington, D.C. 20036  
Telephone: (202) 263-4300  
Fax: (202) 263-4329

October 5, 2005

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FORM PTO-1449  INFORMATION DISCLOSURE STATEMENT		ATTY. DOCKET 033082M275	SERIAL NO. 10/552262 To Be Assigned
		APPLICANT: Kazuhide HASEBE, et al.	
		FILING DATE Herewith	GROUP ART UNIT To Be Assigned

**U.S. PATENT DOCUMENTS**

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	5,282,925	2/1/94	Jeng, et al.			
	AB	5,380,399	1/10/95	Miyashita, et al.			
	AC						
	AD						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**FOREIGN PATENT DOCUMENTS**

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES      NO
	AL	08-195381	7/30/96	Japan			Abstract
	AM	06-224153	8/12/94	Japan			Abstract
	AN	05-326464	12/10/93	Japan			Abstract
	AO	06-97140	4/8/94	Japan			Abstract
	AP						
	AQ						

**OTHER INFORMATION** (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	
AS	

EXAMINER: \_\_\_\_\_ DATE CONSIDERED: \_\_\_\_\_

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.